



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI**

Group Art Unit: **1763**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND
SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. §1.116
EXPEDITED PROCESSING REQUESTED

MAIL STOP AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

August 7, 2006

Sir:

In response to the Office Action dated May 8, 2006, Applicants submit the following remarks.

Remarks begin on page 2 of this paper.